



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TFL  
PATENT

In re application of: ) Attorney Docket No. LAM2P452  
Adrian KIERMASZ )  
Application No. 10/743,923 ) Examiner: M. Rachuba  
Filed: December 22, 2003 ) Group Art Unit: 3723  
For: LINEAR CHEMICAL MECHANICAL ) Confirmation No. 9016  
PLANARIZATION (CMP) SYSTEM AND )  
METHOD FOR PLANARIZING A WAFER ) Date: February 7, 2006  
IN A SINGLE CMP MODULE )

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on February 7, 2006.

Signed:   
Diane Schwanbeck

Commissioner for Patents  
Alexandria, VA 22313-1450

Sir:

Applicant hereby transmits an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims Remaining <u>After Amendment</u>	Highest Previously <u>Paid For</u>	Present <u>Extra</u>	SMALL ENTITY <u>RATE FEE</u>	OR	LARGE ENTITY <u>RATE FEE</u>
TOTAL CLAIMS	<u>05</u> -	<u>20</u>	<u>00</u>	X 25 = \$	OR	X 50 = \$0
INDEP CLAIMS	<u>01</u> -	<u>04</u>	<u>00</u>	X100 = \$	OR	X200 = \$0
[ ] Multiple Dependent Claim Present and Fee Not Previously Paid				\$180		\$360
			TOTAL	\$_____		\$0



Applicant hereby petitions for a \_\_\_\_-month extension of time to respond to the Office Action. Applicant believes that no extension of time is required; however, if it is determined that such an extension is required, Applicant hereby petitions that such an extension be granted and authorize the Commissioner to charge the required fees for an extension of time under 37 CFR 1.136 to Deposit Account No. 50-0805 (Order No. LAM2P452).



Enclosed is our Check No. \_\_\_\_ in the amount of \$\_\_\_\_ to cover the extension of time fees. If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAM2P452).

Respectfully submitted,  
MARTINE PENILLA & GENCARELLA, LLP



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Customer No. 25920



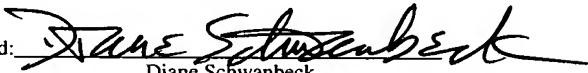
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Diane Schwanbeck

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicant submits this paper in response to the Office Action dated November 7, 2005. Please amend this application as follows:

The **Amendments to the Claims** made herein are reflected in the **Listing of Claims**, which begins on page 2 of this paper.

Applicant's **Remarks** begin on page 4 of this paper.